

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10045849	11/07/2001	204	192.12	1753	MCDONALD, R

**APPLICANTS: Park Young;

**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A CON OF 09/542,799 04/04/2000 ABN *
WHICH CLAIMS BENEFIT OF 60/144,602 07/19/1999

(*)Data provided by applicant is not consistent with PTO records.

** FOREIGN APPLICATIONS VERIFIED:

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☒ no

35 USC 119 conditions met ☐ yes ☒ no

Verified and Acknowledged Examiners's initials *me*

ATTORNEY DOCKET NO

YP-001.C1

TITLE : High throughput thin film deposition and substrate handling method and apparatus for optical disk processing

U.S. DEPT. OF COMM / PAT & TM-PTO-436L (Rev. 12-94) (94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
		Application Examiner	
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	
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FILED WITH: ☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)